

FORM PTO-1449 (Rev. 7-2001)	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. 854163.412	APPLICATION NO. 10/756,195
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)		APPLICANTS Osama Khouri et al.	
		FILING DATE January 13, 2004	GROUP ART UNIT 2813

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
TSP	AA	5,789,277	08/04/98	Zahorik et al.	438	95	
	AB	5,814,527	09/29/98	Wolstenholme et al.	438	5	
	AC	5,952,671	09/14/99	Reinberg et al.	257	3	
	AD	5,970,336	10/19/99	Wolstenholme et al.	438	238	
	AE	6,031,287	02/29/00	Harshfield	257	734	
	AF	6,238,946	05/29/01	Ziegler	438	50	
	AG	6,512,241	01/28/03	Lai	257	4	
	AH	6,541,333	04/01/03	Shukuri et al.	438	243	
	AI	6,613,604	09/02/03	Maimon et al.	438	95	
	AJ	6,617,192	09/09/03	Lowrey et al.	438	95	
	AK	6,750,079	06/15/04	Lowrey et al.	438	95	
	AL	2002/0017701	02/14/02	Klersy et al.	257	536	
	AM	2003/0075778	04/24/03	Klersy	257	536	
	AN	2003/0219924	11/27/03	Bez et al.	438	102	
	AO	2003/0231530	12/18/03	Bez et al.	365	200	
	AP	2004/0012009	01/22/04	Casagrande et al.	257	4	
	AQ	2004/0166604	08/26/04	Ha et al.	438	102	
TSP	AR	09/276,273		Klersy			03/25/99

## FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION	
					YES	NO
TSP	AS	WO 00/57498	09/28/00	WIPO		

EXAMINER /Thanhha Pham/	DATE CONSIDERED 05/23/2006
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\* EXAMINER: Initial if reference considered, whether or not criteria is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant(s).

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	AA						
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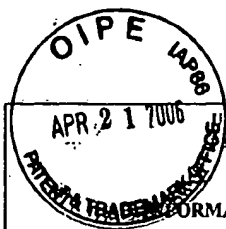
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION	
					YES	NO
	AK					
	AL					
	AM					
	AN					
	AO					

**OTHER PRIOR ART** (Including Author, Title, Date, Pertinent Pages, Etc.)

TSP	AP	Palun, L., et al., "Fabrication of Single Electron Devices by Hybrid (E-Beam/DUV) Lithography," <i>Microelectronic Engineering</i> 53:167-170, 2000.
	AQ	
	AR	

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Sheet 1 of 1

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TSP	AA	6,313,604	11/06/01	Maimon et al.	438	95	
TSP	AB	6,316,784	11/13/01	Zahorik et al.	257	3	
TSP	AC	6,440,837	08/27/02	Harshfield	438	618	
TSP	AD	6,545,287	04/08/03	Chiang	257	3	
TSP	AE	6,586,761	07/01/03	Lowrey	257	3	
TSP	AF	6,943,365	09/13/05	Lowrey et al.	257	3	
TSP	AG	6,969,866	11/29/05	Lowrey et al.	257	3	
TSP	AH	2002/0070401	06/13/02	Takeuchi et al.	257	296	
	AI						
	AJ						

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